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A PDMS-Based Conical-Well Microelectrode Array for Surface Stimulation and Recording of Neural Tissues

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Abstract

A method for fabricating polydimethylsiloxane (PDMS)-based microelectrode arrays (MEAs) featuring novel conical-well microelectrodes is described. The fabrication technique is reliable and efficient, and facilitates controllability over both the depth and the slope of the conical wells. Because of the high PDMS elasticity (as compared to other MEA substrate materials), this type of compliant MEA is promising for acute and chronic implantation in applications that benefit from conformable device contact with biological tissue surfaces and from minimal tissue damage. The primary advantage of the conical-well microelectrodes—when compared to planar electrodes—is that they provide an improved contact on tissue surface, which potentially provides isolation of the electrode microenvironment for better electrical interfacing. The raised wells increase the uniformity of current density distributions at both the electrode and tissue surfaces, and they also protect the electrode material from mechanical damage (e.g. from rubbing against the tissue). Using this technique, electrodes have been fabricated with diameters as small as $10\mu m$ and arrays have been fabricated with center-to-center electrode spacings of $60\mu m$. Experimental results are presented, describing electrode-profile characterization, electrode-impedance measurement, and MEA-performance evaluation on fiber bundle recruitment in spinal cord white matter.

Index Terms

Microelectrode array (MEA); compliant; PDMS; conical-well microelectrode; conically recessed electrode; microfabrication; surface stimulation; surface recording; neural prosthesis

I. Introduction

Extracellular stimulation and recording of neuronal tissue have broad applicability both to scientific studies and to clinical applications. Historically, the majority of applications that elicit functional outputs have used single rigid electrodes inserted into the tissue [1], which provide local access to the targeted neurons. To improve resolution and reliability of both stimulation and recording, multiple-electrode approaches have been developed using semiconductor microfabrication techniques. These multi-electrode arrays are typically fabricated using silicon, glass, and metals [2]–[7], and provide access to and control of proximal neural circuitry.

A significant limitation of these multi-electrode approaches has been their mechanical impedance mismatch with surrounding tissue. This mismatch can lead to significant tissue damage and dysfunction of the device. Reduction of the multiple electrodes' invasiveness can be achieved by using planar multi-electrode arrays that interface only with the tissue surface. This approach has worked effectively in applications where reduced accessibility is an acceptable trade-off. Rigid planar microelectrode arrays (MEAs) have been well-developed and successfully applied in culture studies [8]–[12], but are still ultimately limited by their inability to interface closely with a soft-tissue substrate.

To improve the ability of multiple electrodes to interface closely and effectively with neural tissue surface, MEAs have been fabricated on flexible, thin-film substrates such as polyimide [13]–[15]. These MEAs have been applied to many applications in biomedical engineering [13]–[20]. Although polyimide substrates exhibit a certain level of flexibility, they are not an ideal solution to the challenge of chronic surface stimulation and recording, primarily because the MEAs cannot conform to complex tissue surfaces. In contrast, MEAs fabricated using a truly compliant substrate, such as polydimethylsiloxane (PDMS, i.e. silicone rubber), have the capability of conforming to the tissue surface, which can provide a uniform and tight contact on the target tissue surface [21]–[23]. The combination of surface stimulation and recording with compliant MEAs provides a novel and potentially powerful method for exploring the underlying properties of the nervous system.

Building upon our previous PDMS-based MEA efforts [24], we have developed a new PDMS-based MEA fabrication method that features a conical PDMS well surrounding each microelectrode. These conical-well microelectrodes facilitate an improved tissue surface contact, which potentially provides a more isolated microenvironment for electrical current exchange between the electrode and tissue surface. In addition, this fabrication method is reliable and efficient with easy controllability over the conical well depth and recess slope. In this paper, we describe the fabrication processes, and we present experimental results for electrode-profile characterization, for electrode-impedance measurement, and for conical well surface-contact testing. Finally, we evaluate MEA performance in the mammalian central nervous system via stimulation of spinal white matter tracts implicated in activating locomotor behavior.

II. Methodology

A. Device Fabrication

Briefly, our fabrication process involves curing a thin layer of PDMS onto a glass slide, lift-off patterning gold features, assisting in the formation of conical wells by lithographically defining sacrificial posts where electrode and contact pad openings will be, covering the sample with another thinner PDMS layer for encapsulation, and then removing the sacrificial posts to expose the electrodes and contact pads. Stepwise processes are shown schematically in Fig. 1 and are described in detail below:

1) Preparing PDMS and Glass Slide—PDMS (Sylgard® 184, Dow Corning) elastomer base is mixed with curing agent at 10 : 1 weight ratio, and the mixture is left at room temperature for at least 40 minutes to let air bubbles rise out. A cleaned glass slide is coated with a 250Å non-stick gold layer primed by 100Å titanium in an e-beam evaporator (CVC Products, Inc.), both at 3Å/s, to facilitate device release in the end (Step 1 in Fig. 1). A ~70µm PDMS base layer is formed by spin-coating the prepolymer onto the glass slide at 1500rpm for 15 seconds with a ramp rate of 1000rpm/s. The sample is then cured on a hotplate (Step 2 in Fig. 1).

2) Lift-off Patterning Gold Traces—The sample is first briefly treated in oxygen plasma to activate the PDMS surface [25]. Immediately following this treatment, positive photoresist (Shipley Megaposit SPR 220 7.0) is spin-coated at 1500rpm for 30 seconds with a ramp rate of 300rpm/s. The sample is then cured on a 90°C hotplate with slow ramp up and down to avoid formation of cracks (Step 3 in Fig. 1). The resulting ~12µm photoresist is patterned in a standard photolithography process. Finally, the photoresist mask is flood-exposed to enable subsequent lift-off in its developer (Step 4 in Fig. 1). A hold time of at least 120 minutes is required before starting depositing gold to allow water, which is necessary to complete the photo-reaction, to diffuse back into the photoresist mask. Then, 5000Å gold is deposited at 1Å/s in an e-beam evaporator with a priming layer of 300Å titanium (Step 5 in Fig. 1). After deposition, the sample is soaked in the corresponding photoresist developer (Shipley Microposit MF-319) to dissolve the photoresist and lift off the excess gold film, leaving only the desired gold features (Step 6 in Fig. 1).

3) Defining Sacrificial Posts—Following brief oxygen plasma treatment of the sample, a thick sacrificial layer of negative photoresist (NR5-8000, Futurrex, Inc.) is spin-coated (Step 7 in Fig. 1). The sacrificial layer is patterned to leave posts right on top of each gold electrode and contact pad where an opening is to be made (Step 8 in Fig. 1). The height of these sacrificial posts determines the depth of the conical electrode wells that will form [Fig. 3(b)]. The processing recipe follows the NR5-8000 product datasheet, except that 90. is used during both softbake (60 minutes) and postbake (15 minutes) to avoid cracking gold features by high temperature.

4) Spin-Coating PDMS for Encapsulation—Immediately following oxygen plasma treatment, a second PDMS layer is spin-coated to encapsulate the device at 5000rpm for 150 seconds with a ramp rate of 1000rpm/s. The uncured sample is left at room temperature for

one hour, baked on a 60°C hotplate for one hour, and then baked in a 90°C oven for another hour. The resulting encapsulation thickness is $\sim 10\mu\text{m}$ (Step 9 in Fig. 1). Because of capillary effect, the PDMS prepolymer sticks and rises along the sidewalls of the sacrificial posts. The combination of spin speed, spin duration, and baking conditions is designed to disperse the prepolymer to a film thickness less than the height of the sacrificial posts [26]. Additionally, the processing recipe guarantees that the prepolymer gets rid of the top of sacrificial posts [27], [28]. These conditions and the oxygen plasma pre-treatment are crucial for successfully achieving the conical-well structure.

5) Opening Electrodes and Contact Pads—To remove sacrificial posts, the sample is immersed in acetone for about 10 minutes, and then the electrode area is rinsed briefly with acetone stream. Confirmation that all electrodes have been opened can be achieved through microscope inspection; subsequent acetone soaking and rinsing are applied as necessary until all electrodes are opened (Step 10 in Fig. 1).

6) Detaching the Device from Glass Slide—The completed device is peeled off its glass slide while immersed in isopropanol, which helps to reduce stress and prevent the film from self-adhesion (Step 11 in Fig. 1). Finally, the device is soaked in de-ionized water for 24 hours to remove any chemical residues that may get involved during fabrication.

B. Device Characterization and Evaluation

1) Electrode Profile Characterization—In order to determine the dependence of conical well depth on sacrificial post height, three sets of samples were prepared. Within each set, one sample was made with the sacrificial layer spin-coated at 400rpm, 600rpm, 700rpm, 800rpm, and 1000rpm, respectively. The spin processes were all 30 seconds in duration with a ramp rate of 200rpm/s. Subsequent processing parameters for the sacrificial layer, such as bake time, UV exposure dose, and development time, were adjusted according to the respective thickness. Other fabrication processes were kept the same. On each sample, two five-electrode MEAs were made. Therefore, data of thirty individual measurements on samples from three rounds of fabrication was collected for both post height and well depth at each spin speed. The profilometer (KLA-Tencor P15 Profilometer) settings in our measurements were: scan speed of $50\mu\text{m/s}$, sampling rate of 50Hz, applied force of 0.5mg, stylus tip radius of $2\mu\text{m}$ with a 60° cone angle, and vertical range/resolution of $131\mu\text{m}/0.0781\text{\AA}$.

2) Electrode Impedance Measurement—To measure the electrode impedance, we used the same method and setup as were reported in [24]. The relationship between conical well depth (as determined by sacrificial layer spin speed) and electrode impedance was then quantified. One MEA with the sacrificial layer spin-coated at 400rpm, 600rpm, 700rpm, 800rpm, and 1000rpm, respectively, was tested. Five measurements of electrode impedance on the five individual electrodes of each MEA were taken. Because the PDMS surface is hydrophobic, when the MEA is immersed in water/solution or a solution drop is applied over the electrode area, an air bubble is usually trapped in each of the conical electrode wells, as shown in Fig. 5(a). This problem was prevented by brief oxygen plasma treatment to convert the PDMS surface to hydrophilic in advance [25]. The hydrophilicity lasts for

more than one day (our observation), and can be preserved by storing the sample in de-ionized water [29].

3) Surface Contact Performance of Conical Wells—To test the performance of conical electrode wells when contacting to a surface in solution, an MEA (with its glass slide attached for ease of handling and observing) was immersed in de-ionized water in a Petri dish. A $25 \times 25 \times 0.2$ mm glass slide (0.3g) was placed over the electrodes. The conical wells were then inspected under an optical microscope.

4) Stimulation of the In Vitro Spinal Cord—To evaluate the surface stimulation capability of the conical-well MEA, an *in vitro* preparation of isolated rat spinal cord was used [30]. Preparation of spinal cords was accomplished as detailed previously [31]. Viability of the spinal cord was confirmed prior to and throughout experimentation by observing evoked reflexes in the L2 ventral root following dorsal root L2 stimulation (using bipolar, glass suction stimulating and recording electrodes). The degree of hindlimb-associated motor outputs elicited via MEA surface stimulation was compared to that evoked by a conventional rigid tungsten microelectrode. The conical-well MEA was wrapped around the spinal cord such that its electrodes made continuous contact with the cord surface (Fig. 6). Two-dimensional position of the stimulating electrode pair was mapped relative to pinned roots at T10 and T12 using a microscope grid eyepiece (resolution $< 50\mu m$; Leica). The comparison rigid tungsten microelectrode pair ($5\mu m$ tip diameter, 20– $50\mu m$ inter-electrode distance, Harvard Apparatus, Inc.) was pressed onto the cord surface at the same stimulus location either before or after MEA stimulation trials, using grid measurements for accurate placement. The MEA (through a custom-made electrode clamp) and the tungsten electrode pair were both connected to a multichannel stimulator (STG-2008, Multi Channel Systems). Single, rectangular current pulses ($500\mu A/50\mu s$) were applied to compare responses using the two different electrode types. A total of three isolated spinal cords were studied. For two of the spinal cords, an adjacent pair of MEA electrodes stimulated the dorsolateral funiculus (DLF) at thoracic levels 10 to 13. For the third spinal cord, an MEA electrode pair stimulated the ventrolateral funiculus (VLF) at thoracic level 12. Eight stimulus trials were conducted for each electrode type at a given site on the spinal cord surface. Evoked responses to spinal cord stimulation were recorded at vL2 and vL5 [32] (Fig. 7) and analyzed using Clampfit (Molecular Systems) and customized Matlab programs (Mathworks). The strengths of evoked responses [Fig. 7(b) and Fig. 7(d)] were quantified by integrating the rectified response signal for 60ms post-stimulus artifact [Fig. 7(a) and Fig. 7(c), yellow boxes] and subtracting from that value a rectified, pre-stimulus baseline value of equal duration.

III. Results

While the fabrication method can be adapted for customized MEAs with many electrodes, conical-well MEAs each of five electrodes (designed diameter $80\mu m$, minimum electrode spacing $230\mu m$) were fabricated (Fig. 2) and used in experiments that characterized the electrode profile and electrode impedance, and that evaluated the interfacing performance. The following sections describe these experimental results.

A. Electrode Profile Characterization

Our MEA features microelectrodes with a unique conical-well structure. To determine and measure the key fabrication parameters for such a structure, electrode profile was characterized as the sacrificial post height was varied. Sacrificial post height is important, because uncured PDMS prepolymer adheres to and rises along sidewall of the sacrificial post, and under the given processing conditions, a final height is achieved as a result of the balance between capillary force and gravity.

Fig. 3(a) shows a profilometer scan along the dark line in Fig. 2(b). Since the profilometer probe scanned from left to right, well depths were measured as the vertical distance between Point A and B in Fig. 3(a). The inner wall of the well had a slightly conically-recessed shape [Fig. 2(c) and Fig. 3(a)]. This shape was created by the sacrificial post, which had a complementary, tapered shape due to non-uniform UV exposure dose through the thick photoresist layer [33] (Step 8 in Fig. 1). Such a particular shape provides an expected advantage of preventing the top edge of the well from bending inward into the well opening when making contact to a surface [Fig. 5(b)].

However, in Fig. 3(a), the profilometer measurement is inaccurate in reflecting both the actual slope of the inner wall and the actual electrode opening diameter, due to the relatively large size of the probe and a possible shift of the scanning track from moving along the electrode diameter. Scanning electron microscope (SEM) measurements showed that the actual electrode diameters were 20% ~ 40% larger (depending on the depth of the well) than that was designed on the photomask, e.g., $\sim 100\mu\text{m}$ instead of $80\mu\text{m}$ for the sample in Fig. 2. This expansion of electrode size was caused primarily by PDMS shrinking as a result of release of embedded strains after removal of the sacrificial post in acetone.

The statistical dependence of conical well depth on sacrificial post height at different sacrificial layer spin speeds is shown in Fig. 3(b). Although there appear to be large deviations at some spin speeds, it was found during data analysis that both the post height and the electrode well depth were uniform across the five electrodes of each MEA, which is important for providing a consistent interfacial contact. Generally, a conical well depth at the value of about one electrode radius is found to have the best overall performance [34], [35].

B. Electrode Impedance Measurement

Fig. 4 shows the average electrode impedance curves corresponding to each sacrificial layer spin speed, and TABLE I gives the average impedance values at 1kHz. It is seen that, at most frequencies, the electrode impedance is higher when the spin speed is lower. Slower spin speed results in thicker sacrificial layer, which subsequently results in more significantly tapered sacrificial posts due to non-uniform UV exposure dose through the photoresist layer. Consequently, slower spin speed, which ultimately results in a smaller actual electrode opening area and a deeper electrode well, was shown to correspond to higher electrode impedance. This is because electrode impedance is inversely correlated to the actual electrode opening area and directly correlated to parasitic impedances potentially building up on the inner wall of the electrode well.

The results in Fig. 4 and TABLE I, on the whole, confirm the expected relationship between sacrificial layer thickness and electrode impedance. However, slight mismatches do exist; potential reasons for these deviations include variations in electrode surface roughness between certain electrodes, as well as the degree of presence of residues on certain electrode surfaces. Also, for sacrificial layers of close thicknesses, like those resulted from 800rpm and 1000rpm spins, the tapered effects were not strictly in a descending order due to potential UV over-or under-exposure. Therefore, some of the actual electrode opening areas deviated from the normal trend, causing mismatches in the statistical results.

Fig. 4 together with TABLE I indicates that the electrode impedances compare favorably to those of rigid-substrate MEA electrodes [10], [11], [36], and are relatively uniform across electrodes.

C. Surface Contact Performance of Conical Wells

Fig. 5(b) shows the interfacial contact between the conical electrode wells and a thin glass slide. It can be seen that each electrode well forms a perfect seal (the light rings surrounding each electrode) on the glass surface, without any inward bending. Moreover, it was observed that when the thin glass slide was initiated a slight displacement with respect to the MEA, the electrode wells still sealed to the original sites, despite being stretched to irregular shapes (image not shown). As a result of the conformability and elasticity of PDMS material combined with the special structure of the electrode well, it is also expected that, in a similar manner, the conical-well electrode can potentially create a highly isolated micro-environment on the neural tissue surface, which could improve the efficacy of electrical current exchange during neural interfacing.

D. Stimulation of the In Vitro Spinal Cord

Our preliminary comparisons of the MEA vs. rigid tungsten microelectrode demonstrate that the MEA is similar to rigid tungsten microelectrodes in its ability to evoke ventral root outputs via spinal cord surface stimulation. When placed on T12 DLF (n=2), the MEA and rigid tungsten microelectrode evoked vL2 responses with similar strengths [data for one of two spinal cords shown in Fig. 7(a) and Fig. 7(b)]. Also similarly, both electrode types evoked little to no response at vL5. The MEA, when placed at T12 VLF (n=1), evoked ventral root vL2 and vL5 responses with similar shape and timing characteristics as responses evoked by the rigid tungsten microelectrode [Fig. 7(c), indicated by arrows]. However, the strength of evoked vL2 and vL5 responses was greater for the MEA than for the rigid tungsten microelectrode [Fig. 7(d)]. Together, these results from stimulating with the MEA and rigid tungsten microelectrode at these two physiologically-relevant spinal cord sites [37]–[42] demonstrate that the MEA is capable of eliciting motor outputs in a similar manner to traditional rigid electrodes, and confirm the suitability of the MEA for use in future surface stimulation studies in spinal cord.

IV. Discussion

A. Fabrication Considerations

Our fabrication method has demonstrated the achievement of PDMS-based MEAs with conical-well microelectrodes for improved surface contact. Moreover, it is a clean process in that no metal wet etch is involved, thus no etchant residue is potentially left in the device. Preliminary results showed that our fabrication method could achieve a single electrode with minimum diameter of $\sim 10\mu\text{m}$, a 10×10 electrode array with minimum electrode diameter of $20\mu\text{m}$ ($60\mu\text{m}$ center-center electrode distance), and a single trace with thinnest width of $10\mu\text{m}$. Some thoughts with regard to our fabrication method are discussed below:

1) Method for Patterning Gold Features—Many methods have previously been explored for patterning metal films on PDMS substrate, including using shallow mask [22], laser cutting [23], metal transfer [43], wet etch [24], and lift-off [21], [28]. We have chosen the lift-off method for its high resolution, flexibility on pattern design, as well as process compatibility and cleanness. However, lift-off on PDMS substrate is much harder than on a rigid substrate like silicon or glass, primarily due to its large coefficient of thermal expansion (CTE, $\sim 310\text{ppm}/^\circ\text{C}$ [44]). Additionally, most stripping liquids, like acetone, used in rigid-substrate lift-off processes are not compatible with PDMS substrate, because they can easily deform the substrate and lift off all desired features. Thus, most negative photoresists are not suitable in our process due to their difficulty in stripping after development without using solvents, with the exception that a compatible stripper exists (e.g. RR4 or RR41 from Futurrex for its NR series, as has been used in [27]). Considering these, we focused on developing an efficient, high-resolution lift-off method using a positive photoresist with its developer as the stripper.

The positive photoresist we finally chose (Shipley Megaposit SPR 220 7.0) can produce robust high-resolution features and adheres strongly to the activated PDMS surface: although a few cracks may develop after baking, no pieces come off during processing. Most other photoresists, including both positive and negative, do not adhere to the PDMS substrate strongly enough; as a result, small cracked pieces drop off during development. Additionally, the lack of a strong adhesion of these other photoresists to PDMS substrate results in small photoresist features being lifted off the PDMS substrate during development.

The thickness of the photoresist mask is also very important for an efficient and complete lift-off. We have determined that a $12\mu\text{m}$ layer is optimal for achieving lift-off with feature sizes no smaller than $10\mu\text{m}$. The SPR 220 7.0 mask layer can be easily dissolved by the mild developer MF-319, with the condition that it should be flood-exposed before depositing metal film on. Also, MF-319 is compatible and clean for the process.

2) Acetone Effects on PDMS—It was interesting that while we found acetone could not be used for stripping in our lift-off process (because it deformed the PDMS substrate and caused gold features to be stripped off), we could use it to remove sacrificial posts for opening electrodes and contact pads. Our encapsulated devices were found robust enough to withstand being soaked in acetone for an hour during sacrificial post removal! It was believed that the surface properties of PDMS in the encapsulated device changed following

our processing, which made it harder for acetone to get into the polymer. Nevertheless, PDMS thin films are not suitable to be soaked in acetone for too long. About an hour would be the maximal limit, and longer immersion may cause PDMS to be 'dissolved' by acetone.

3) Sacrificial Posts for Opening Electrodes and Contact Pads—The selection of a suitable photoresist for making sacrificial posts depended on several key factors. The associated processing of the chosen photoresist needed to be compatible with the PDMS substrate and previous processes. Also, the chosen photoresist needed to be PDMS-philic (after oxygen plasma activation) for the formation of electrode wells and capable of producing features with superior resolution and aspect ratio. Finally, the photoresist needed to be removable with a compatible process in the end. After exploration, we finally found the negative photoresist NR5-8000 (Futurrex, Inc.) could meet all the above requirements. Results also show that, with proper process parameters, planar electrodes could be fabricated [27], [28], [45].

B. Advantages of Conical-Well Electrodes

The major perceived advantage of the conical-well electrode is its potential to provide an optimal functional interface with soft tissue. Evidences of this potential are explained in detail below, and are described in relation to our investigations concerning the physical, electrical, and mechanical attributes of such MEAs.

1) Providing Good Suction Interface for Surface Contact—As demonstrated in *Section III. C*, when contacting to a flat glass surface, the conical electrode wells each formed a tight seal. In a similar manner, it is expected that conical-well microelectrodes, when interfaced with soft tissues, would provide an interface with a more isolated micro-environment for current exchange between the electrode and tissue surface. With this seal, little current leakage should occur, and stimulation would be more power-efficient with improved spatial selectivity. However, more sophisticated experiments need to be designed to further investigate such a potential.

2) Producing Uniform Current Density Profile—For near-field electrical stimulation, in which the targeted tissue is immediately adjacent to or in direct contact with the electrode surface, charge density (the product of current density and pulse duration), together with charge per phase, is considered responsible for stimulation induced neural damage [46]. Excess current density at the electrode surface can also cause electrode damage by initiating irreversible electrochemical reactions. Safe stimulation levels are thus set by limiting the maximum average current density at the electrode surface and the maximum average charge injection into the tissue per phase.

For non-recessed disk electrodes, peak current density builds up at electrode-insulator edges [47]. Theoretical analyses [34] and experimental measurements [35] have demonstrated that excess current density at the electrode edges can be reduced or eliminated by recessing the electrode into the carrier, creating a welled electrode, and by radially varying the recess. Thus, recessed electrodes could significantly reduce tissue damage by preventing the

electrode surface from irreversible electrochemical reactions and by protecting the targeted tissue from being exposed to high peak current density.

Our conical-well electrode features a conical recess, which is molded by a tapered sacrificial post. The recess slope can be set by controlling sidewall slope of the sacrificial post [45], and the recess depth can be set by controlling height of the sacrificial post [Fig. 3(b)]. Uniform distributions of current density are expected at both the electrode surface and the conical-well aperture where interface junction is to be made with targeted tissue surface [35]. Not only will current be released uniformly across the electrode surface, thereby minimizing electrode damage, but also the maximum amount of current can be injected uniformly across the conical-well aperture into the targeted tissue, thus maximizing activation capability while minimizing direct tissue damage normally caused by edge-induced excess peak current density.

3) Protecting Electrodeposited Material—Previous work has demonstrated that platinum-black [48], [49], iridium oxide [50], and conducting polymers [51], [52] can be electrodeposited onto electrode surface. Such electrodeposition benefits electrode designs by reducing electrode impedance and increasing charge injection capability. The conical-well structure is expected to facilitate such electrodeposition efforts by protecting the deposited material from mechanical removal. However, the deposited rough material in the well could disturb the uniformity of current density distributions. Therefore, a tradeoff between electrode impedance reduction, charge injection increase, and current density uniformity must be optimized. This can be accomplished by appropriate control of material deposition and by adjusting the conical well profile with respect to well depth and recess slope.

C. Potential Applications

This PDMS-based conformable MEA technology could benefit numerous applications that require conformable device contact with biological tissue surfaces and that require minimal tissue damage that often results from rigid electrodes. For example, the fabrication method we have developed has the potential for producing efficient interfaces for high-resolution prostheses on the surface of the retina, cortex, and spinal cord: applications in which conformable thin-film MEAs of high capacity and high electrode density are desired. Most electrical stimulation applications would benefit from the conical-well electrode feature, because its uniform current-density profile provides the advantage of minimal tissue damage and electrode corrosion; this advantage is particularly important for chronic implantation. For recording applications, the conical wells have the potential to facilitate better-isolated electrodes, thus reducing leakage and noise and increasing signal fidelity.

Although we have used compliant PDMS (Sylgard 184, Dow Corning) as both the substrate and encapsulation materials and have used gold to make the interconnects, the fabrication technique also has the potential for implementing conical-well MEAs on other substrates, either rigid or flexible, and with other metals or conducting polymers used for the interconnects. The advantages of conical-well MEAs fabricated using other materials would open the technology to a broader range of applications. For example, silicon, glass, or polyimide can be used for the substrate, and SU-8, polyimide or PDMS can be used for

encapsulation; the resulting planar devices would have applicability to *in vitro* applications—such as brain-slice studies—in which the uniform current density profile and potentially higher signal fidelity of the conical wells can be exploited.

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Fig. 1. Schematic illustration of stepwise fabrication processes for the PDMS-based conical-well microelectrode array.

Fig. 2.

Images of a five-electrode, conical-well MEA at different scales. The sacrificial layer of this sample was spin-coated at 600rpm. (a) The MEA. (b) Optical microscope image of the conical-well microelectrodes. The dark line over the top two electrodes indicates the scanning track along which the conical-well microelectrode profiles in Fig. 3(a) were measured. (c) Scanning electron microscope (SEM) image of the conical-well microelectrodes. The diameter of the electrodes was designed to be $80\mu\text{m}$. SEM measurements here show top and bottom diameters of $\sim 120\mu\text{m}$ and $\sim 100\mu\text{m}$, respectively. The expansion of electrode size was caused primarily by PDMS shrinking as a result of release of embedded strains after removal of the sacrificial post in acetone.

Fig. 3.

Characterization of conical-well microelectrode profile. (a) A profilometer scan along the dark line in Fig. 2(b). The sacrificial layer of this sample was spin-coated at 400rpm. Well depth was measured as the vertical distance between Point A and B. (b) Statistical dependence of conical well depth on sacrificial post height at different sacrificial layer spin speeds. Each point on the plot corresponds to measurements on 30 individual electrodes from three rounds of fabrication. Each group of data is fitted by a second-order polynomial curve (the dotted line).

Fig. 4.

Electrode impedance measurement. Average electrode impedance curves corresponding to each sacrificial layer spin speed are shown. Curves with one standard deviation from the average electrode impedance corresponding to a sacrificial layer spin-coated at 400rpm are also shown as dotted lines.

Fig. 5.

Optical microscope images for surface contact performance of conical electrode wells. (a) An MEA with its glass slide attached for ease of handling and observing was immersed in de-ionized water in a Petri dish. An air bubble was trapped in each of the conical electrode wells due to hydrophobicity of the PDMS surface. These bubbles can be avoided by brief oxygen plasma activation of the PDMS surface in advance. (b) Interfacial contact between conical electrode wells and a thin glass slide placed over. Air bubbles were avoided. Each electrode well formed a good seal (the light rings surrounding each electrode) on the glass surface, without any inward bending.

Fig. 6.

Experimental setup for comparing spinal cord responses to surface stimulation with the conical-well MEA vs. rigid tungsten electrode. Studies were performed to determine the capability of the conical-well MEA to access motor circuitry in the *in vitro* rat isolated spinal cord, as compared to a rigid tungsten microelectrode (inset, placed on location immediately between the two left-most MEA electrodes, location indicated by arrows). Single-pulse stimuli were delivered to the surface of the cord and motor output responses were recorded at ventral roots L2 (vL2, red) and L5 (vL5, blue).

Dorsolateral funiculus stimulation: Rigid Electrode vs. MEA (n=2)

Ventrolateral funiculus stimulation: Rigid Electrode vs. MEA (n=1)

Fig. 7.

Ventral root responses to surface stimulation of the spinal cord, rigid electrode vs. MEA. A pair of MEA electrodes (bipolar configuration) and a rigid bipolar tungsten electrode were used to stimulate the spinal cord at surface sites on thoracic level 12 (T12) dorsolateral funiculus (DLF) and ventrolateral funiculus (VLF) (n=3 cords). A microscope grid eyepiece was used to measure and replicate surface positional coordinates across electrode types. Shown are ventral root L2 (vL2) and ventral root L5 (vL5) responses to MEA and rigid electrode stimulation at T12 DLF [Fig. 7(a), data from 1 of 2 cords shown] and T12 VLF [Fig. 7(c)]. Eight stimulus trials were conducted per electrode type; these response traces are shown time-distributed. The strength of evoked responses was quantified by integrating the

rectified response signal (post stimulus artifact) and subtracting from that value a rectified, pre-stimulus baseline of equal duration [60ms; Fig. 7(b) and Fig. 7(d)]. Standard error bars are shown. Time windows during which stimulus artifact was observed (indicated by gray boxes) were not included in the time range over which strengths of response were measured (yellow boxes). Initial ventral root responses to stimuli can be observed within and after the stimulus artifact (as indicated by arrows), which indicates that stimulus artifact presents a limitation to the accuracy of the strength-of-response calculations. Ventral root L2 (vL2) responses to DLF stimulation were similar in strength for both electrodes, and vL5 responses were similarly small or undetectable using both electrode types [Fig. 7(b)]. For VLF stimulation, the pattern of vL2 and vL5 responses was similar across electrode types, with larger responses evoked at L2 [Fig. 7(d)]. At the T12 VLF, stronger responses were evoked on both vL2 and vL5 for MEA stimulation *vs.* rigid electrode stimulation.

TABLE I
Average electrode impedances at 1kHz corresponding to each sacrificial layer spin speed (impedance unit: k Ω)

	400rpm	600rpm	700rpm	800rpm	1000rpm
1kHz	106.44	81.538	71.405	56.632	57.072